# RD42 Organization Chart

**Spokespersons**
Harris Kagan, William Trischuk

Params
H. Kagan

3D
A. Oh

Materials Work

Manufacturers

E6
W. Trischuk

II-VI
H. Kagan

Pad, Strip, Pixel Devices

BLM, BCM, Lumi Devices

Beam Tests

Irradiations

ATLAS Pix
H. Kagan

CMS Pixel
D. Hits

ATLAS
M. Mikuz

CMS
M. Guthoff

CERN
A. Gorisek

PSI
D. Hits

LANL
S. Seidel

JSI/LJU
V. Cindro

Pad, Strip
AG + HK

LHC
D. Hits

CERN
M. Goffe